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XA-9907
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Haruki FUKAI et al.

Appln. No.: 10/616,923

Group Art Unit: 2828

Filed: July 11, 2003

Examiner: J. Menefee

For: SEMICONDUCTOR LASER, MANUFACTURING THE SAME AND
SEMICONDUCTOR FOR LASER DEVICE

* * *

RESPONSE

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

Responding to the Office Action mailed March 29, 2005,
and to the requirement for restriction therein, Applicants
elect Group II (Claims 6-14) without traverse, reserving
the right to file a divisional application with regard to
the non-elected invention.


An action on the merits of the claims to the elected
invention is respectfully requested.

The Commissioner is hereby authorized to charge to
Deposit Account No. 50-1165 any fees under 37 C.F.R. §§1.16
and 1.17 which may be required by this paper, and to credit

any overpayment to that Account. If any extension of time is required in connection with the filing of this paper and has not been requested separately, then such extension is hereby requested.

Respectfully submitted,

By:



Mitchell W. Shapiro
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MWS:kss

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April 29, 2005